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Expedited Examining Procedure
Response -Under 37 C.F.R. §1.116
Group 1765

PATENT
Docket No. 150.00560104

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Lee et al.)	Group Art Unit:	1765
)		
Serial No.:	10/050,639)	Examiner:	Duy Deo
Confirmation No.:	6476)		
)		
Filed:	January 15, 2002)		
)		
For:	METHOD AND COMPOSITION FOR SELECTIVELY ETCHING AGAINST COBALT SILICIDE			

RESPONSE UNDER 37 CFR §1.116

Assistant Commissioner for Patents
Mail Stop AF
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The following remarks are provided in response to the Final Office Action mailed November 4, 2003.

Remarks begin on the page entitled "Remarks."